See discussions, stats, and author profiles for this publication at: https://www.researchgate.net/publication/231433220

Low-Temperature Growth of the Infinite Layer Phase of SrCuO2 by Pulsed Laser Deposition

ARTICLE in JOURNAL OF THE AMERICAN CHEMICAL SOCIETY · APRIL 1992

Impact Factor: 12.11 · DOI: 10.1021/ja00035a070

CITATIONS	READS
12	20

2 AUTHORS:



Chunming Niu
Xi'an Jiaotong University

49 PUBLICATIONS 2,481 CITATIONS

SEE PROFILE



Charles M Lieber

Harvard University

476 PUBLICATIONS 82,045 CITATIONS

SEE PROFILE

Scientific Research on Priority Area (No. 03215229)] is gratefully acknowledged.

Supplementary Material Available: Analytical data including ${}^{1}H$ NMR, ${}^{13}C$ NMR, IR, $[\alpha]_{D}$, HRMS, and combustion data for the key compounds, $\mathbf{4}$ - α , $\mathbf{4}$ - β , $\mathbf{8}$, and $\mathbf{1}$ (3 pages). Ordering information is given on any current masthead page.

Low-Temperature Growth of the Infinite Layer Phase of SrCuO₂ by Pulsed Laser Deposition

Chunming Niu and Charles M. Lieber*

Department of Chemistry and Division of Applied Sciences Harvard University, Cambridge, Massachusetts 02138 Received February 4, 1992

The products obtained from conventional solid-state synthetic reactions are often limited to the high-temperature thermodynamic ones, 1,2 and thus there has been considerable interest in developing new low-temperature approaches that might provide access to novel phases and materials. For example, several groups have described the use of low-temperature reactive fluxes to prepare new metal-chalcogenide phases, 3,4 and other researchers have investigated the low-temperature synthesis of inorganic solids via the controlled decomposition of molecular precursors.⁵ Herein, we report a strikingly different approach for low-temperature solid-state synthesis based on pulsed laser deposition (PLD), and we use this method to prepare the tetragonal infinite layer phase of SrCuO₂. The tetragonal phase of SrCuO₂ is an important target since it represents the parent structure of the high-temperature copper oxide superconductors; however, it is inaccessible by conventional high-temperature synthetic routes.

PLD is a well-established technique for the preparation of thin film materials.⁶⁻⁹ It involves ablation of a target material with a high-energy pulsed laser, and deposition of the evaporated target material onto a substrate to yield a thin film product. There are several features of the ablation and deposition processes that make PLD ideally suited for the synthesis of new materials, including the following: (1) material is congruently evaporated from the target during rapid laser heating; (2) growth of a crystalline product can be carried out at temperatures significantly lower than

(1) DiSalvo, F. J. Science 1990, 247, 649.

(4) (a) Kanatzidis, M. G.; Huang, S.-P. J. Am. Chem. Soc. 1989, 111, 760.
(b) Kanatzidis, M. G.; Park, Y. J. Am. Chem. Soc. 1989, 111, 3767.
(c) Kanatzidis, M. G. Chem. Mater. 1990, 2, 353.
(5) (a) Steigerwald, M. L.; Rice, C. E. J. Am. Chem. Soc. 1988, 110, 4228.
(b) Steigerwald, M. L. Chem. Mater. 1989, 1, 52.
(c) Brennan, J. G.; Siegrist, Steightlin, 1989, 1, 52.

(5) (a) Steigerwald, M. L.; Rice, C. E. J. Am. Chem. Soc. 1988, 110, 4228.
(b) Steigerwald, M. L. Chem. Mater. 1989, 1, 52. (c) Brennan, J. G.; Siegrist, T.; Stuczynski, S. M.; Steigerwald, M. L. J. Am. Chem. Soc. 1990, 112, 9233.
(d) Banaszak Holl, M. M.; Wolczanski, P. T.; Van Duyne, G. D. J. Am. Chem. Soc. 1990, 112, 7989.

(6) (a) Cheung, J. T.; Sankur, H. Crit. Rev. Solid State Mater. Sci. 1988, 15, 63. (b) Olander, D. R. High Temp. Sci. 1990, 27, 411. (c) Paine, D. C.; Bravman, J. C. Laser Ablation for Materials Synthesis; Materials Research

Bravinan, J. C. Luser Abilition for Materials Synthesis; Materials Research Society: Pittsburgh, 1990.
(7) (a) Xi, X. X.; Venkatesan, T.; Li, Q.; Wu, X. D.; Inam, A.; Chang, C. C.; Ramesh, R.; Hwang, D. M.; Ravi, T. S.; Findikoglu, A.; Hemmick, D.; Etemad, S.; Martinez, J. A.; Wilkens, B. IEEE Trans. Magn. 1991, 27, 2.
(b) Koren, G.; Gupta, A.; Baseman, R. J.; Lutwyche, M. I.; Laibowitz, R. B. Appl. Phys. Lett. 1989, 55, 2450. (c) Izumi, H.; Ohata, K.; Sawada, T.; Morishita, T.; Tanaka, S. Appl. Phys. Lett. 1991, 59, 597. (d) Gupta, A.; Braren, B.; Casey, K. G.; Hussey, B. W.; Kelly, R. Appl. Phys. Lett. 1991, 59, 1302.

(8) (a) Triscone, J.-M.; Fischer, O.; Brunner, O.; Antognazza, L.; Kent, A. D.; Karkut, M. G. *Phys. Rev. Lett.* **1990**, *64*, 804. (b) Lowndes, D. H.; Norton, D. P.; Budai, J. D. *Phys. Rev. Lett.* **1990**, *65*, 1160. (c) Matsumoto, T.; Kawai, T.; Kitahama, K.; Kawai, S. *Appl. Phys. Lett.* **1991**, *58*, 2039. (d) Kawai, T.; Egami, Y.; Tabata, H.; Kawai, S. *Nature* **1991**, *349*, 17.

(9) (a) Norton, D. P.; Lowndes, D. H.; Sales, B. C.; Budai, J. D.; Chakoumakos, B. C.; Kerchner, H. R. Phys. Rev. Lett. 1991, 66, 1537. (b) Fincher, C. R.; Blanchet, G. B. Phys. Rev. Lett. 1991, 67, 2902. (c) Tabata, H.; Murata, O.; Kawai, T.; Kawai, S. Appl. Phys. Lett. 1990, 56, 1576.

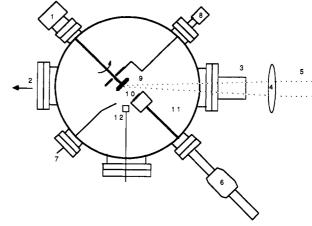


Figure 1. Schematic view of the PLD chamber. Major components: (1) target rotation feedthrough, (2) turbomolecular pump, (3) quartz window, (4) focus lens, (5) excimer laser, (6) substrate manipulator, (7) gas inlet, (8) substrate shutter, (9) target, (10) substrate, (11) substrate heater, (12) quartz crystal thickness monitor.

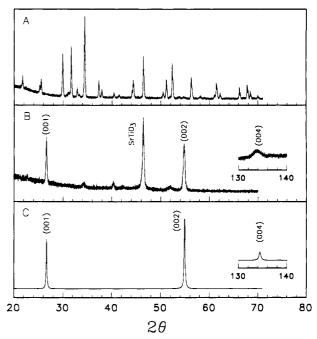


Figure 2. Experimental X-ray diffraction patterns for (A) the orthorhombic SrCuO₂ target and (B) a 5000-Å SrCuO₂ film prepared by PLD. A simulated diffraction pattern for c-axis oriented tetragonal SrCuO₂ is shown in part C.

those of conventional solid-state reactions; (3) the substrate can be chosen to enforce the growth of a specific structural phase; and (4) sequential multitarget evaporation can be used to prepare complex layered structures with atomic-level control. 6-8 An indication of the potential of PLD for materials synthesis has been the growth of high-quality, epitaxial films of copper oxide superconductors, because these materials are compositionally complex and melt incongruently. There are few studies, however, that have utilized the unique characteristics of PLD for new materials synthesis. 9

Our PLD experiments were carried out in a stainless steel vacuum chamber that is evacuated with a turbomolecular pump (Figure 1). The SrCuO₂ target material was prepared by conventional high-temperature methods from a 1:1 mixture of SrCO₃ and CuO.¹⁰ This preparative route yields an orthorhombic phase

^{(2) (}a) Hagenmuller, P. Preparative Methods in Solid State Chemistry; Academic Press: New York, 1972. (b) Rao, C. N. R.; Gopalakrishnan, J. New Directions in Solid State Chemistry; Cambridge University Press: New York, 1986.

^{(3) (}a) Sunshine, S. A.; Kang, D.; Ibers, J. A. J. Am. Chem. Soc. 1987, 109, 6202. (b) Keane, P. M.; Lu, Y.-J.; Ibers, J. A. Acc. Chem. Res. 1991, 24, 223.

⁽¹⁰⁾ Stoichiometric amounts of CuO (99.999%, Johnson Matthey) and SrCO₃ (99.999%, Johnson Matthey) were ground, heated at 800 °C for 12 h, reground, and heated at 900 °C for 24 h. Finally, the resulting polycrystalline powder was pressed into a pellet and sintered at 950 °C.

with a = 3.57 Å, b = 16.34 Å, and c = 3.91 Å (Figure 2A).¹¹ Notably, ablation of orthorhombic SrCuO₂ targets using a KrF excimer laser (248 nm) and deposition of the ablated material onto <100> oriented SrTiO₃ substrates at 500 °C yields a new structural phase with a 1:1 Sr:Cu stoichiometry.¹² X-ray diffraction patterns (θ -2 θ scans) of the new SrCuO₂ films can be indexed as a tetragonal SrCuO₂ layered phase with the c-axis oriented perpendicular to the substrate surface (Figure 2B). The c-axis lattice parameter calculated from these experimental data is 3.35 Å. To support our structural assignment of the product, we have simulated the diffraction pattern for tetragonal SrCuO₂ (Figure 2C). The excellent agreement between the experimental and simulated patterns shows that the product obtained by PLD is the infinite layer phase. Small impurity peaks that can be indexed as the (111) and (061) peaks of the orthorhombic phase are also observed in the experimental diffraction scans at 2θ = 34.4° and 40.3°. Since this impurity represents <10% of the product, we conclude that the major phase produced in our lowtemperature PLD studies is tetragonal SrCuO₂.

The tetragonal phase of SrCuO₂ represents the parent structure of the layered copper oxide superconducting materials and has thus been an important synthetic target of solid-state chemists. The tetragonal phase is, however, inaccessible to conventional high-temperature approaches, except for the specific stoichiometry $Sr_{0.14}Ca_{0.86}CuO_2$. ^{13,14} Unfortunately, the subtle ionic size effects that stabilize the tetragonal phase for this compound preclude systematic investigations of doping. Several groups have also reported that tetragonal SrCuO2 can be prepared at high temperatures by applying very high pressures (20-65 kbar) during reaction.16,17 These studies offer a general approach to the tetragonal phase (as does PLD), although the instrumentation needed to achieve ultrahigh pressure is available in relatively few laboratories compared to laser deposition systems. The highlyoriented crystalline samples obtained by PLD are also ideal for detailed physical measurements, in contrast to ceramic samples obtained from high-pressure syntheses.

We have carried out a number of studies to elucidate the factors that control the growth of the layered phase. First, we find that as the SrCuO₂ growth temperature is increased from 500 to 700 °C, there is a decrease in the degree of c-axis orientation of the tetragonal phase, and there is an increase in the percentage of orthorhombic phase formed. In addition, PLD of the thermodynamically stable tetragonal compound $Sr_{0.14}Ca_{0.86}CuO_2$ between 500 and 700 °C yields only tetragonal-phase product. 14,15 These results strongly indicate that low-temperature growth (accessible by PLD) kinetically traps the metastable tetragonal phase of SrCuO₂. We also find that there are a decrease in the degree of c-axis orientation of the tetragonal phase and an increase in the percentage of orthorhombic impurity phase for films grown on MgO (a = 4.2 Å) versus SrTiO₃ (a = 3.905 Å). Since the a-axis lattice parameter of tetragonal $SrCuO_2$ (a = 3.92 Å) is better matched for epitaxial growth on SrTiO₃, we suggest that

(11) Teske, V. C. L.; Muller-Buschbaum, H. Z. Anorg. Allg. Chem. 1970, 379, 234.

the substrate also helps to stabilize the desired tetragonal phase. In summary, we have utilized the unique characteristics of PLD to prepare highly oriented films of tetragonal SrCuO₂. The ready accessibility of high-quality crystalline samples of this material offers an outstanding opportunity to study electronic and magnetic consequences of doping in this model system¹⁸ and suggests in general the potential of PLD for new materials synthesis.

Acknowledgment. We thank Dr. E. M. Carnahan for helpful discussions. C.M.L. acknowledges support of this work by the NSF, the David and Lucile Packard Foundation, and a Camille and Henry Dreyfus Teacher-Scholar Award.

Supplementary Material Available: Experimental X-ray diffraction patterns for a tetragonal $Sr_{0.14}Ca_{0.86}CuO_2$ ceramic target and a 5000-Å $Sr_{0.14}Ca_{0.86}CuO_2$ film prepared by PLD and a simulated diffraction pattern for c-axis oriented tetragonal $Sr_{0.14}Ca_{0.86}CuO_2$ (1 page). Ordering information is given on any current masthead page.

(18) Niu, C. M.; Lieber, C. M. In preparation.

W₆(H)₅(O-*i*-Pr)₁₃. A Polynuclear Polyhydride Supported Exclusively by Alkoxide Ligands

Malcolm H. Chisholm,* Keith S. Kramer, and William E. Streib

Department of Chemistry and Molecular Structure Center Indiana University, Bloomington, Indiana 47405 Received November 7, 1991

Complexes of transition metals with metal-hydrogen bonds are of critical importance in many stoichiometric and catalytic reactions.^{1,2} Since the initial discovery of HCo(CO)₄ and H₂Fe-(CO)₃ in the 1930s, the chemistry of metal hydrides and metal polyhydrides has been developed with the now classical ligands of organometallic chemistry, namely, carbon monoxide, tertiary phosphines, cyclopentadienes, and related soft π -acceptor ligands. It has been our belief that hard π -donor ligands such as alkoxides (siloxides and aryloxides) should also support an extensive organometallic chemistry for the early transition metals in their higher oxidation states where there are vacant d_x orbitals.³ Within this field a potentially important class of compounds are metal hydrides supported by alkoxide ligands, $M_x(H)_v(OR)_z$. The first well-characterized member of this series was $\dot{W}_4(H)_2(O-i-Pr)_{14}^4$ followed by related $W_2(H)(OR)_7L^5$ and $NaW_2(H)(OR)_8^6$ complexes. For tantalum, Wolczanski and co-workers⁷ reported the synthesis of $[(silox)_2Ta(H)_2]_2$, where silox = $(t-Bu)_3SiO$, and its reactions with carbon monoxide. More recently, Rothwell and co-workers8 have characterized a novel stereochemically rigid seven-coordinated tantalum(V) trihydride supported by attendant aryloxide ligands: $TaH_3(OAr')_2L_2$, where $L = PMe_2Ph$ and Ar'= 2,6-R₂C₆H₃, and found that these and related niobium complexes provide catalysts for the cis-hydrogenation of fused aromatic rings.8 Hoffman et al.9 reported the reversible formation of

⁽¹²⁾ The ablation was carried out with a laser power density of 1-2 J/cm² and a repetition rate of 5 Hz. The oxygen pressure during deposition was 10 mTorr. The Sr:Cu ratio determined by electron microprobe analysis (Cameca MBX) was 1:1 for films prepared under these conditions.

⁽¹³⁾ Siegrist, T.; Zahurak, S. M.; Murphy, D. W.; Roth, R. S. Nature 1988, 334, 231.

⁽¹⁴⁾ We have also prepared films of $Sr_{0.14}Ca_{0.86}CuO_2$ compound by PLD. Diffraction analyses (supplementary material) show that the thermodynamically stable tetragonal layered phase is obtained as c-axis oriented films for growth temperatures between 500 and 700 °C. The $Sr_{0.14}Ca_{0.86}CuO_2$ film c-axis (3.28 Å) is smaller than that observed for $SrCuO_2$ (3.35 Å), as expected. $^{13.15}$ The similarity of the diffraction results obtained for the $SrCuO_2$ and $Sr_{0.14}Ca_{0.86}CuO_2$ PLD products further supports our structural assignment for $SrCuO_2$.

 ⁽¹⁵⁾ Kanai, M.; Kawai, T.; Kawai, S. Appl. Phys. Lett. 1991, 58, 771.
 (16) (a) Smith, M. G.; Manthiram, A.; Zhou, J.; Goodenough, J. B.;
 Markert, J. T. Nature 1991, 351, 549. (b) Er, G.; Miyamoto, Y.; Kanamaru,
 F.: Kikkawa. S. Physica C 1991, 181, 206.

F.; Kikkawa, S. *Physica C* 1991, 181, 206. (17) (a) Takano, M.; Takeda, Y.; Okada, H.; Miyamoto, M.; Kusaka, T. *Physica C* 1989, 159, 375. (b) Takano, M.; Azuma, M.; Hiroi, Z.; Bando, Y. *Physica C* 1991, 176, 441.

⁽¹⁾ Cotton, F. A.; Wilkinson, G. Advanced Inorganic Chemistry, 5th ed.; Wiley: New York, 1988; Chapter 24.

⁽²⁾ Hlatky, G. G.; Crabtree, R. H. Coord. Chem. Rev. 1985, 65, 1.

⁽³⁾ Buhro, W. E.; Chisholm, M. H. Adv. Organomet. Chem. 1987, 27, 311. (4) (a) Akiyama, M.; Little, D.; Chisholm, M. H.; Haitko, D. A.; Cotton, F. A.; Extine, M. W. J. Am. Chem. Soc. 1979, 101, 2504. (b) Akiyama, M.; Chisholm, M. H.; Cotton, F. A.; Extine, M. W.; Haitko, D. A.; Leonelli, J.;

Little, D. J. Am. Chem. Soc. 1981, 103, 779.
(5) Chacon, S. T.; Chisholm, M. H.; Folting, K.; Hampden-Smith, M. J.; Huffman, J. C. Inorg. Chem. 1991, 30, 3122.
(6) Chisholm, M. H.; Huffman, J. C.; Smith, C. A. J. Am. Chem. Soc.

⁽⁶⁾ Chisholm, M. H.; Huttman, J. C.; Smith, C. A. J. Am. Chem. Soc. 1986, 108, 222.

(7) (a) La Painte, R. F.; Wolczanski, P. T. I. Am. Chem. Soc. 1986, 108

 ^{(7) (}a) LaPointe, R. E.; Wolczanski, P. T. J. Am. Chem. Soc. 1986, 108,
 3535. (b) Toreki, R.; LaPointe, R. E.; Wolczanski, P. T. J. Am. Chem. Soc.
 1987, 109, 7558.

⁽⁸⁾ Ankianiec, B. C.; Fanwick, P. E.; Rothwell, I. P. J. Am. Chem. Soc. 1991, 113, 4710.

⁽⁹⁾ Hoffman, D. M.; Lappas, D.; Wierda, D. A. J. Am. Chem. Soc. 1989, 111, 1531.